



61

AF/1963

## AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): ASEEEM K. SRIVASTAVA ET AL.

Docket No.

01-SM5-216

Serial No.  
09/905,043Filing Date  
07/13/2001Examiner  
P. HASSANZADEHGroup Art Unit  
1763Invention: METHOD AND APPARATUS FOR MICRO-JET ENABLED, LOW-ENERGY ION GENERATION  
AND TRANSPORT IN PLASMA PROCESSING

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TO THE COMMISSIONER FOR PATENTS:

OCT 20 2003

TC 1700

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

## CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	18 -	32 =	0	x \$18.00	\$0.00
INDEP. CLAIMS	2 -	3 =	0	x \$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

No additional fee is required for amendment.

Please charge Deposit Account No. in the amount of

A check in the amount of to cover the filing fee is enclosed.

The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 06-1130

Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.

Signature

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Dated: October 10, 2003

I certify that this document and fee is being deposited on 10/10/2003 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

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Typed or Printed Name of Person Mailing Correspondence



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: ASEEM K. SRIVASTAVA, ET AL. )  
Serial No.: 09/905,043 ) Group Art Unit: 1763  
Filed: July 13, 2001 )  
For: METHOD AND APPARATUS FOR )  
MICRO-JET ENABLED, LOW-ENERGY ) Examiner: Hassanzadeh, P.  
ION GENERATION AND TRANSPORT )  
IN PLASMA PROCESSING ) Confirmation No.: 2232

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed September 4, 2003, please amend  
the Application as follows: